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Attorney Docket No. 108298738US
Disclosure No. 03-0618.00/US

PTO/SB/21 (09-04)

Approved for use through 07/31/2006. OMB 0651-0031

U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE

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TRANSMITTAL FORM (to be used for all correspondence after initial filing)		Application Number	10/683,606-Conf. #1013
		Filing Date	October 9, 2003
		First Named Inventor	Garo J. Derderian
		Art Unit	1762
		Examiner Name	David P. Turocy
Total Number of Pages in This Submission	15*	Attorney Docket Number	108298738US

ENCLOSURES (Check all that apply)		
☐ Fee Transmittal Form	☐ Drawing(s)	☐ After Allowance Communication to TC
☐ Fee Attached	☐ Licensing-related Papers	☐ Appeal Communication to Board of Appeals and Interferences
☐ Amendment/Reply	☐ Petition	☐ Appeal Communication to TC (Appeal Notice, Brief, Reply Brief)
☐ After Final	☐ Petition to Convert to a Provisional Application	☐ Proprietary Information
☐ Affidavits/declaration(s)	☐ Power of Attorney, Revocation Change of Correspondence Address	☐ Status Letter
☐ Extension of Time Request	☐ Terminal Disclaimer	☒ Other Enclosure(s) (please Identify below):
☐ Express Abandonment Request	☐ Request for Refund	Check in the amount of \$180
☒ Information Disclosure Statement	☐ CD, Number of CD(s) _____	Return Receipt Postcard
☐ Certified Copy of Priority Document(s)	☐ Landscape Table on CD	Certificate of Mailing
☐ Reply to Missing Parts/Incomplete Application		Form PTO/SB/08
☐ Reply to Missing Parts under 37 CFR 1.52 or 1.53		Cited References (64)
Remarks		

SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT		
Firm Name	PERKINS COIE LLP	
Signature		
Printed name	Paul T. Parker	
Date	3 June 2005	Reg. No. 38,264

* Number of pages does not include Cited References

Transmittal Form (1 page)
Information Disclosure Statement (2 pages)
Form PTO/SB/08 (13 pages)
Cited References (64)
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Disclosure No. 03-0618.00/US

(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Derderian et al.

Application No.: 10/683,606

Confirmation No.: 1013

Filed: October 9, 2003

Art Unit: 1762

For: APPARATUS AND METHODS FOR
PLASMA VAPOR DEPOSITION
PROCESSES

Examiner: David P. Turocy

INFORMATION DISCLOSURE STATEMENT (IDS)

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO/SB/08. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

his Information Disclosure Statement is filed more than three months after the U.S. filing date, OR more than three months after the date of entry of the national stage of a PCT application, AND after the mailing date of the first Office Action on the merits, whichever occurs first, but before the mailing date of a Final Office Action or Notice of Allowance (37 CFR 1.97(c)).

A copy of the U.S. Applications and Patents listed on the PTO/SB/08 has not been provided. A copy of each Non-U.S. Patent and each Non-Patent Literature article listed on

the PTO/SB/08 is attached. A full translation of the non-English language references marked by a check mark (✓) is enclosed. An abstract is enclosed for all other non-English language references. Applicant has not verified that the translation or abstract is an accurate representation of the teachings of the non-English reference, though, and reserves the right to demonstrate otherwise.

In accordance with 37 CFR 1.97(g), the filing of this Information Disclosure Statement shall not be construed to mean that a search has been made or that no other material information as defined in 37 CFR 1.56(a) exists. In accordance with 37 CFR 1.97(h), the filing of this Information Disclosure statement shall not be construed to be an admission that any patent, publication or other information referred to therein is "prior art" for this invention unless specifically designated as such.

It is submitted that the Information Disclosure Statement is in compliance with 37 CFR 1.98 and the Examiner is respectfully requested to consider the listed references.

Our check in the amount of \$180.00 covering the fee set forth in 37 CFR 1.17(p) is enclosed. The Director is hereby authorized to charge any deficiency in the fees filed, asserted to be filed or which should have been filed herewith (or with any paper hereafter filed in this application by this firm) to our Deposit Account No. 50-0665, under Order No. 108298738US.

Dated: 3 June 2005

Respectfully submitted,

By PTK

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PTO/SB/08a/b (08-03)
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U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE
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Substitute for form 1449A/B/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)				Complete If Known	
				Application Number	10/683,606-Conf. #1013
				Filing Date	October 9, 2003
				First Named Inventor	Garo J. Derderian
				Art Unit	1762
				Examiner Name	David P. Turocy
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U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)			
		US-10/767,298	Filed 01-28-2004	Zheng et al.	
		US-11/027,825	Filed 12-29-2004	Derderian et al.	
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Sheet	2	of	13	Attorney Docket Number	108298738US

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Sheet	3	of	13	Attorney Docket Number	108298738US

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Sheet	4	of	13	Attorney Docket Number	108298738US

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Sheet	6	of	13	Attorney Docket Number	108298738US

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Sheet	7	of	13	Attorney Docket Number	108298738US

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